

Notice of References Cited

Application/Control No.

10/552,970

Applicant(s)/Patent Under
Reexamination
CIRKEL ET AL.

Examiner

TAI DUONG

Art Unit

2871

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0043291	11-2001	Kono et al.	349/12
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	M	US-			

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NON-PATENT DOCUMENTS

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